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Patent

1763

Attorney's Docket No.: 4936 USA/ETCH/METAL/JB1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Steven Verhaverbeke et al.

U.S. Serial No: 09/945,454

Filed: August 31, 2001

For: A METHOD AND APPARATUS
FOR PROCESSING A WAFER

Examiner: Moore, Karla A.

Art Unit: 1763

#10B
6/2/03
mwCommissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450SUPPLEMENTAL AMENDMENT AND RESPONSE

Dear Sir:

This is in response to the Office Action mailed December 5, 2002 and the Notice of Non-Compliant Amendment mailed May 14, 2003. Applicant respectfully requests the Examiner to enter the following amendments and consider the following remarks.

FIRST CLASS CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to MAIL STOP _____
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